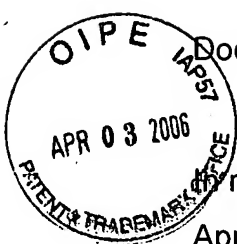


JPW



Docket No. EATNP160US

03-IMP-035

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re **PATENT** application of:

Applicant: Mehran Asdigha et al.
Application No.: 10/840,186
For: MECHANICAL OSCILLATOR FOR WAFER SCAN WITH SPOT BEAM
Filing Date: May 6, 2004
Examiner: David A. Vanore
Art Unit: 2881

REPLY TO OFFICE ACTION DATED FEBRUARY 1, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.